

Transaction Information

Tool ID	LKTK759
Tool Status	Running Wafers
Location	Woodlands, Singapore
Wafer Size	300 mm
Fab Section	Lithography
Tool Available Date	2023-12-01

General Product Information

Vendor Supplier	TEL
Model	LITHIUS
Vintage	2006
Serial No	G260815
Asset Description	TEL LITHIUS KRF DUV Track
Software Version	3.00.71
CIM	SECS
Process	KRF

Hardware Configuration (Fab)

System Type	Description	Quantity	Status
Main System	TCU	1	OK
Main System	Main Tool	1	OK
Main System	COT	3	OK
Main System	TCT	2	OK
Main System	DEV	5	OK
Handler System	CRA	1	OK
Handler System	IRAS	1	OK
Factory Interface	FOUP	4	OK
Options System			
Others			

Hardware Configuration (Subfab / Auxilliary Units)

Description	Quantity	Status
T&H Controller	1	OK
DEV Chemical Cabinet	1	OK
AC Power Box	1	OK
COT Chemical Cabinet	1	OK

Missing/Faulty Parts / Accesories List

Description	Quantity
None	0

Tool Pictures

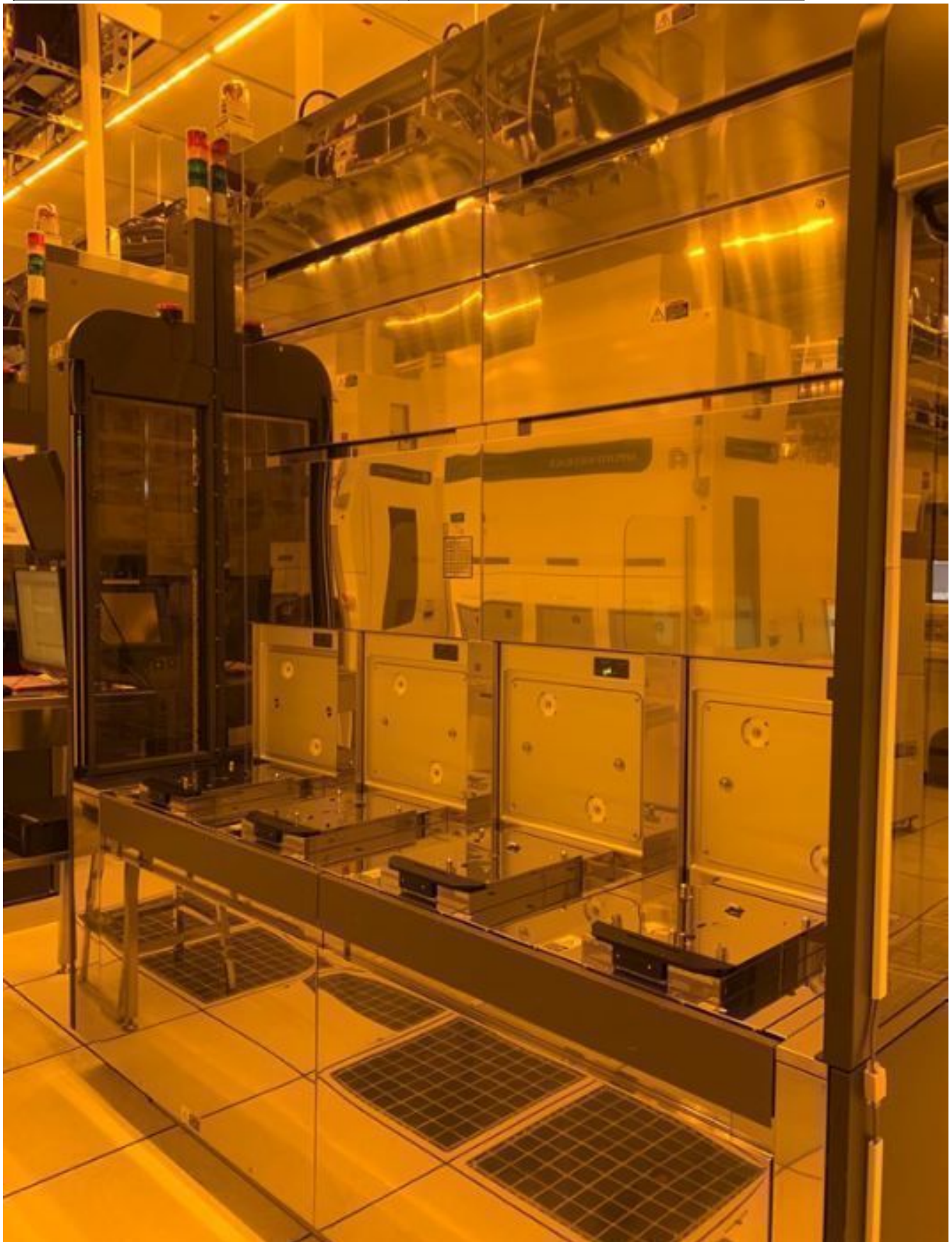
General | LKTK759 Machine Configuration

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1 CONFIGURATION

CONFIGURATION

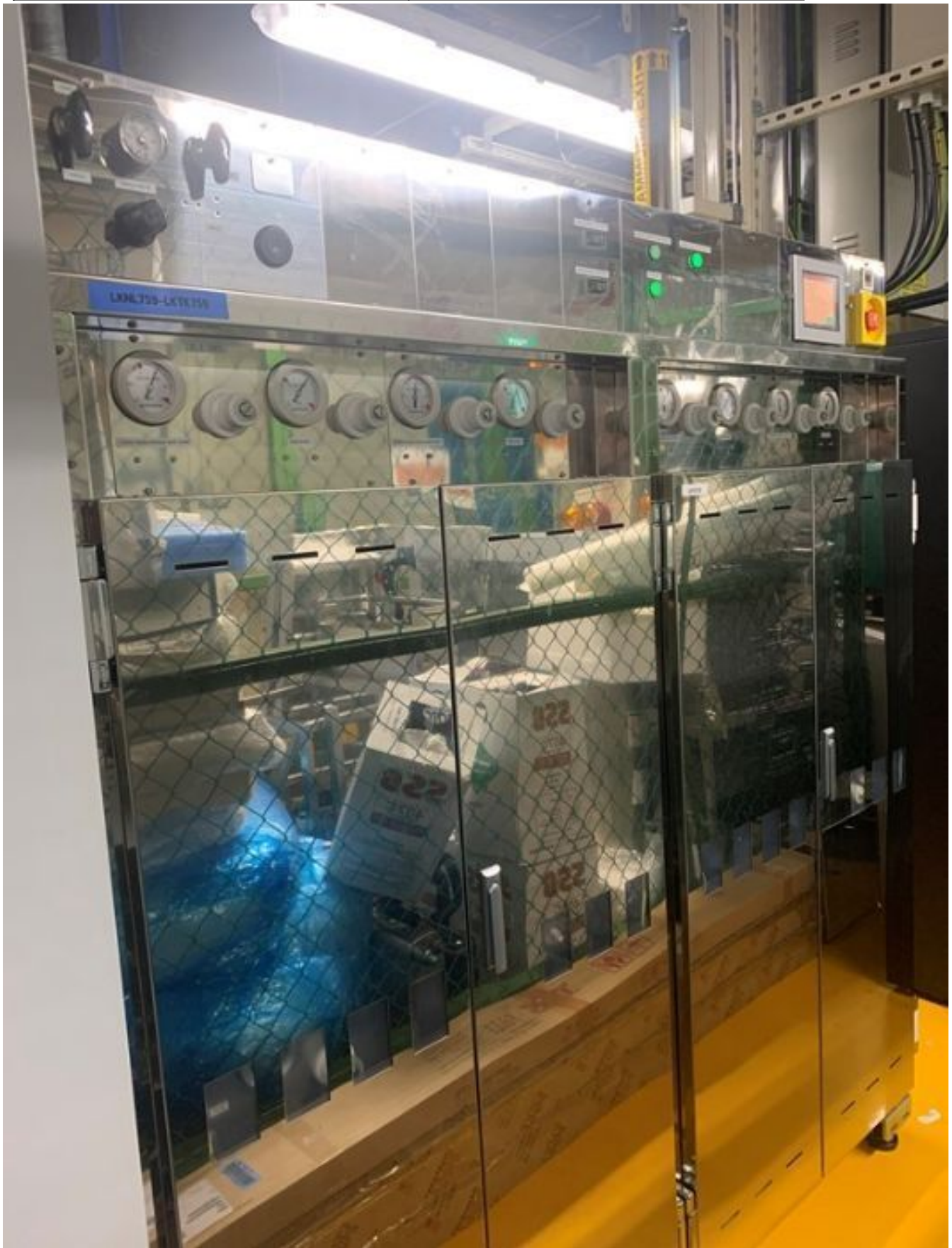
5-0	IRAS	4-9	BWEE	3-23	3-36	2-49	CPHP	2-58	CW1+4	2-23	1-0	GRA	1-4	FOUP					
		4-8		3-18	CPHP	3-35	LHP	2-44	CPHP	2-57					CW1+1	2-18	CPHP		
		4-7	SBU	3-17	CPHP	3-34	LHP	2-43	CPHP	2-56					ADH	2-17	CPHP		
		4-6	SBU	3-16	CPHP	3-33	LHP	2-42	CPHP	2-55					ADH	2-16	CPHP		
				3-15	CPHP	3-32	LHP	2-41	CPHP	2-54					ADH	2-15	CPHP		
				3-14	CPHP			2-40	CPHP							2-14	CPHP		
				3-13				2-39								2-13			
				3-12	CPHP			2-38	HCP							2-12	HCP		
				3-11				2-37								2-11			
				4-0	IRAM	3-10	CPHP	3-0	PRA	2-36					HCP	2-0	PRA	2-10	HCP
				3-9				2-35	TRS							2-9	TRS		
				3-8	HCP			2-34	WCPL							2-8	WCPL		
				3-7				2-33								2-7	TRS		
				3-6	HCP			2-32	HCP							2-6	HCP		
		4-5	THS			3-5	DEV			2-5	TCT								
		4-4				3-4	DEV			2-4	TCT								
		4-3	TRS			3-3	DEV			2-3	COT								
		4-2	IHCP			3-2	DEV			2-2	COT								
		4-1	IHCP			3-1	DEV			2-1	COT								

※本図はCONF10の情報のみ示しています。
 ※ This figure shows only module configuration.













Manufacture Serial

LKTK759 Serial Number



Additional Configuration Files

Additional Configuration Files

	Machine ID	G260815
	Software	3.00.71
	Tool Model	TEL LITHIUS
	Block	2 Blocks
CSB	Loadport	4
PRB1	TCT	2
	COT	3
	HCP	6
	WCPL	2
	ADH	3
	CPHP	11
PRB2	DEV	5
	HCP	2
	CPHP	7
	LHP	4
IFB	BWEE	1
	IHCP	2
Others	Pump Type	Entegris RGEN-02 4cc Entegris RGEN-02 10cc
	Dev Nozzle Type	NLD Nozzle
Accessories	AC Power Box	1
	T&H Controller	Asahi
	Chemical Cabinet	2